

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hisaji OYAKE et al.

10/500008

Application No.: New U.S. National Stage of
PCT/JP02/13876

DT09 Rec'd PCT/PTO 23 JUN 2004

Filed: June 23, 2004

Docket No.: 120155

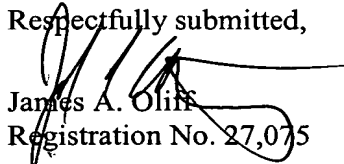
For: METHOD OF MANUFACTURING STAMPER FOR MANUFACTURING
INFORMATION MEDIUM, STAMPER, AND PHOTORESIST MASTERINFORMATION DISCLOSURE STATEMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references 1-8, 10-11 and 14 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- ☒ 3. English-language Abstracts of the non-English language references 1-13 are attached hereto.
- ☒ 4. A computer-generated English translation of the following Japanese reference(s) has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 1-9.

Respectfully submitted,


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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 120155		APPLICATION NO. New U.S. National Stage of PCT/IP02/13876 <div style="font-size: 2em; font-weight: bold; text-align: center;">10/500008</div>	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Hisaji OYAKE et al.			
				FILING DATE June 23, 2004		GROUP	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	1.	JP A 2000-280255 w/abstract & transl.	10/10/2000	JAPAN		
	2.	JP A 2001-184734 w/abstract & transl.	7/6/2001	JAPAN		
	3.	JP A 5-214547 w/abstract & transl.	8/24/1993	JAPAN		
	4.	JP A 6-215422 w/abstract & transl.	8/5/1994	JAPAN		
	5.	JP A 8-185643 w/abstract & transl.	7/16/1996	JAPAN		
	6.	JP A 8-273219 w/abstract & transl.	10/18/1996	JAPAN		
	7.	JP A 9-109276 w/abstract & transl.	4/28/1997	JAPAN		
	8.	JP A 8-283950 w/abstract & transl.	10/29/1996	JAPAN		
	9.	JP A 9-292715 w/abstract & transl.	11/11/1997	JAPAN		
	10.	JP A 3-180476 w/abstract	8/6/1991	JAPAN		
	11.	JP A 4-263140 w/abstract	9/18/1992	JAPAN		
	12.	JP A 3-180476 w/abstract	8/6/1991	JAPAN		
	13.	JP A 4-263140 w/abstract	9/18/1992	JAPAN		
	14.	WO96/32521	10/17/1996	WIPO		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						

EXAMINER	DATE CONSIDERED
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Date: June 23, 2004